


<b>Search Notes</b> 	<b>Application/Control No.</b> 10596963	<b>Applicant(s)/Patent Under Reexamination</b> LEHTONEN, KAI
	<b>Examiner</b> Christopher S Kim	<b>Art Unit</b> 3752

SEARCHED			
Class	Subclass	Date	Examiner
239	88-95, 570-574, 533.3-533.12		
137	494, 543.15, 514.5		
123	446-447, 496, 500-501, 50 6	9/20/09	CK

SEARCH NOTES			
Search Notes		Date	Examiner
137/ J. Rivell			
123/ T. Moulis (X-re in 123/496)		9/20/09	CK

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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